

thereon formed by vacuum deposition, and where in said code is formed by evaporation of the metal layer by means of the laser device to define a pattern or discernible code on each micro particle.

6. (Amended) A method according to claim 1, wherein the substrate comprises a plastic material and said code is formed by burning holes in said substrate to define a pattern or discernible code on each micro particle.

7. (Amended) A method as claimed in claim 5, wherein said pattern or discernible code comprises a series of digits.

8. (Amended) A method according to claim 1, wherein the substrate sheet is affixed to the support by means of a suitable adhesive.

A1 9. (Amended) A method according to claim 1, wherein the support comprises a flat sheet of inert material.

A2
A2 11. (Amended) A method according to claim 1, wherein the micro particles are removed from the support by the use of a suitable solvent.

12. (Amended) A method according to claim 1, including the further step of suspending the micro particles in a suitable